IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen a Serial No: 09/667,362 Confirmation No: 9755

Filed: Sep 21, 2000

Title: REDUCING DEPOSITION OF

PROCESS RESIDUE ON A WINDOW OF A CHAMBER

Group Art Unit: 1763

Examiner: Unknown

Attorney Docket No:

002813 USA P01/ETCH/SILICON/JB

November 27, 2001

San Francisco, California

SUBMISSION OF FORMAL DRAWINGS

Commissioner of Patents and Trademarks Washington, D.C. 20231

Attention: Official Draftsperson

Sir:

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TO 1700

Enclosed are sixteen (16) sheets of formal drawings for the above-identified application .

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

> Commissioner for Patents Washington, D.C. 20231

Attention: Official Draftsperson

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It is believed that no fee or petition is associated with this communication. If, however, any fee or petition is due, Applicant hereby petitions the Commissioner for the same, and authorizes the Commissioner to charge payment of any fees associated with this communication to Deposit Account No. 10-0258. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Dated: November 27, 2001

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